	Application No.	Applicant(s)
	09/901,438	HASEGAWA ET AL.
Notice of Allowability	Examiner	Art Unit
	Christopher R. Magee	2653
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in this apply or other appropriate communication (RIGHTS). This application is subject	oplication. If not included n will be mailed in due course. THIS
1. This communication is responsive to the IDS filed 06/07/2	<u>2005</u> .	
2. X The allowed claim(s) is/are 17-46.		
 3. Acknowledgment is made of a claim for foreign priority of a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents 	re been received. re been received in Application No	
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONI THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a reply MENT of this application.	complying with the requirements
 A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give 	nitted. Note the attached EXAMINEF res reason(s) why the oath or declar	R'S AMENDMENT or NOTICE OF ation is deficient.
5. CORRECTED DRAWINGS (as "replacement sheets") mu	st be submitted.	
(a) I including changes required by the Notice of Draftsper	son's Patent Drawing Review (PTO	-948) attached
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date	<u>_</u> .	
(b) including changes required by the attached Examiner Paper No./Mail Date	's Amendment / Comment or in the	Office action of
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in	1.84(c)) should be written on the draw the header according to 37 CFR 1.121	ings in the front (not the back) of (d).
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT 	osit of BIOLOGICAL MATERIAL FOR THE DEPOSIT OF BIOLOGIC	must be submitted. Note the CAL MATERIAL.
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5 Notice of Informal I	Potent Application (PTO 452)
 Notice of References Cited (P10-092) District Notice of Draftperson's Patent Drawing Review (PT0-948) 	6. ☐ Interview Summary	Patent Application (PTO-152)
	Paper No./Mail Da	ite
 Information Disclosure Statements (PTO-1449 or PTO/SB/ Paper No./Mail Date 06/07/2005 	08), 7. ☐ Examiner's Amend	ment/Comment
4. Examiner's Comment Regarding Requirement for Deposit	8. X Examiner's Statem	ent of Reasons for Allowance
of Biological Material	9.	/ 1 0 1 2
12/20/2005		Anyl Castro C
12/20/2005 // Mar —		ANGEL CASTRO PRIMARY EXAMINER

O.S. Patent and Trademark Office PTOL-37 (Rev. 7-05)

DETAILED ACTION

Election/Restrictions

1. Claims 1-16 and 47-78 are withdrawn from further consideration pursuant to 37 CFR 1.142(b), as being drawn to a nonelected species, there being no allowable generic or linking

claim. Applicant timely traversed the restriction (election) requirement in the reply filed on

12/27/2004.

2. Applicant's election of Species B (claims 17-46) in the reply filed on 12/27/2004 is

acknowledged. Because applicant did not distinctly and specifically point out the supposed

errors in the restriction requirement, the election has been treated as an election without traverse

(MPEP § 818.03(a)).

Priority

3. Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

Information Disclosure Statement

4. The information disclosure statement (IDS) submitted on 06/07/2005 was filed after the mailing date of the Notice of Allowance on 3/23/2005. The submission is in compliance with the provisions of 37 CFR 1.97. Accordingly, the examiner has considered the information disclosure statement.

Application/Control Number: 09/901,438 Page 3

Art Unit: 2653

Reasons for Allowance

5. Claims 17-46 are allowed (renumbered as 1-30, respectively).

6. The following is an examiner's statement of reasons for allowance:

This application is for an EXCHANGE COUPLING FILM AND MAGNETORESISTIVE ELEMENT USING THE SAME.

• Claim 17 specifies an exchange coupling film, which requires:

"wherein second imaginary line in the diffraction diagrams of the antiferromagnetic layer and the ferromagnetic layer, the secondary imaginary lines each connecting the beam origin and a particular one of the diffraction spots which is given the same label in both the diffraction diagrams of the antiferromagnetic layer and the ferromagnetic layer and which is located in a direction other than the layer thickness direction when viewed from the beam origin, are not coincident with each other."

Fukuzawa et al. (US 6,338,899 B1) show a diffraction diagram of the antiferromagnetic layer with a dispersion angle of half value width in the <111> direction [Fig. 20; col. 50, lines 58]. Fukuzawa et al. do not teach and/or suggest a second imaginary line in the diffraction diagrams of the antiferromagnetic layer and the ferromagnetic layer, the secondary imaginary lines each connecting the beam origin and a particular one of the diffraction spots which is given the same label in both the diffraction diagrams of the antiferromagnetic layer and the ferromagnetic layer and which is located in a direction other than the layer thickness direction when viewed from the beam origin, are not coincident with each other as claimed in the present invention.

Fuke et al. (US 5,976,713) show an electron beam diffraction pattern of the antiferromagnetic layer oriented in one plane [Figs. 8 and 9; col. 8, lines 46-50]. Fuke et al. do

not teach and/or suggest a second imaginary line in the diffraction diagrams of the antiferromagnetic layer and the ferromagnetic layer, the secondary imaginary lines each connecting the beam origin and a particular one of the diffraction spots which is given the same label in both the diffraction diagrams of the antiferromagnetic layer and the ferromagnetic layer and which is located in a direction other than the layer thickness direction when viewed from the beam origin, are not coincident with each other as claimed in the present invention

Therefore, these features, in combination with other features of claim 17 are not anticipated by, nor made obvious over, the closest prior art of record Fukuzawa et al. (US 6,338,899 B1) and/or Fuke et al. (US 5,976,713).

• Claim 32 specifies an exchange coupling film, which requires:

"wherein a particular diffraction spot indicative of a particular crystal plane, located in a direction other than the layer thickness direction, appears only in one of the diffraction diagrams of the antiferromagnetic layer and the ferromagnetic layer."

Fukuzawa et al. (US 6,338,899 B1) show a diffraction diagram of the antiferromagnetic layer with a dispersion angle of half value width in the <111> direction (Fig. 20; col. 50, lines 58). Fukuzawa et al. do not teach and/or suggest a particular diffraction spot indicative of a particular crystal plane, located in a direction other than the layer thickness direction, appears only in one of the diffraction diagrams of the antiferromagnetic layer and the ferromagnetic layer as claimed in the present invention.

Fuke et al. (US 5,976,713) show an electron beam diffraction pattern of the antiferromagnetic layer oriented in one plane [Figs. 8 and 9; col. 8, lines 46-50]. Fuke et al. do not teach and/or suggest a particular diffraction spot indicative of a particular crystal plane, located in a direction other than the layer thickness direction, appears only in one of the

diffraction diagrams of the antiferromagnetic layer and the ferromagnetic layer as claimed in the present invention.

Therefore, these features, in combination with other features of claim 32 are not anticipated by, nor made obvious over, the closest prior art of record Fukuzawa et al. (US 6,338,899 B1) and/or Fuke et al. (US 5,976,713).

7. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

8. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Christopher R. Magee whose telephone number is (571) 272-7592. The examiner can normally be reached on M-F, 8: 00 am-5: 30 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, William Korzuch can be reached on (571) 272-7589. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Application/Control Number: 09/901,438

Art Unit: 2653

Page 6

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

December 20, 2005

Christopher R. Magee

Patent Examiner Art Unit 2653

crm

ANGEL CASTRO
PRIMARY EXAMINER

ful Costro C